	Application No.	Applicant(s)	
Notice of Allowability	10/617,839	ZHANG ET AL.	¥
	Examiner	Art Unit	
	John S. Maples	1745	
The MAILING DATE of this communication apperation apperation being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313 1. This communication is responsive to 2. The allowed claim(s) is are 1-18. 3. The drawings filed on 11 July 2003 are accepted by the Extended Communication is made of a claim for foreign priority under the communication is made of a claim for foreign priority under the communication is made of the priority documents have and the communication is made of the priority documents have and communication is responsive to 1. Certified copies of the priority documents have and copies of the priority documents have and copies of the certified copies of the priority documents have and copies of the certified copies of the priority documents have and copies of the certified copies of the priority documents have and copies of the certified copies of the priority documents have and copies of the certified copies of the priority documents have and copies of the certified copies of the priority documents have and copies of the certified copies of the priority documents have and copies are certified copies of the priority documents have and copies are certified copies of the priority documents have and copies are certified copies of the priority documents have and copies are certified copies of the priority documents have and copies are certified	ears on the cover sheet wing (OR REMAINS) CLOSED in corother appropriate community of the c	or the correspondence addressing this application. If not included unication will be mailed in due cour subject to withdrawal from issue at long or (f).	rse. THIS the initiative
noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 5. A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give	ENT of this application. itted. Note the attached EXA	AMINER'S AMENDMENT or NOTIC	
6. CORRECTED DRAWINGS (as "replacement sheets") mus (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the T. DEPOSIT OF and/or INFORMATION about the depose attached Examiner's comment regarding REQUIREMENT Replacements.	t be submitted. on's Patent Drawing Review s Amendment / Comment or 84(c)) should be written on the he header according to 37 CFI sit of BIOLOGICAL MATE	v (PTO-948) attached in the Office action of the drawings in the front (not the back R 1.121(d). ERIAL must be submitted. Note the	
 Attachment(s) 1. Notice of References Cited (PTO-892) 2. Notice of Draftperson's Patent Drawing Review (PTO-948) 3. Information Disclosure Statements (PTO-1449 or PTO/SB/06 Paper No./Mail Date	5. ☐ Notice of Inf 6. ☐ Interview Su Paper No./I 8), 7. ☐ Examiner's A	formal Patent Application (PTO-152 ummary (PTO-413), Mail Date Amendment/Comment Statement of Reasons for Allowand	

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1. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Balkanski show producing a solid state battery of interest; the production of a solid electrolyte using a Li source and a P source is disclosed by the patent to Takeuchi et al. and Breitkopf et al. describe an atmospheric pressure chemical vapor deposition grown lithium ion conducting electrolyte.

2. The following is an examiner's statement of reasons for allowance: none of the prior art of record teach the method for producing a solid electrolyte thin film comprising providing a plasma source that is coupled to a plasma gas so that a plasma stream is directed to a substrate, vaporizing a lithium precursor, vaporizing a phosphate precursor and then transporting both of the precursors to the plasma source, expelling both of the precursors from the plasma source and into the plasma stream so that both precursors do not mix with the plasma gas before the gas is expelled as the plasma stream. The art does not disclose the above steps of vaporizing the two precursors and then combining the same with the plasma stream which results in the formation of a solid electrolyte thin film.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

3. Any inquiry concerning this communication or earlier communications from the examiner should be directed to John S. Maples whose telephone number is 571-272-1287. The examiner can normally be reached on Monday-Thursday from 6:15-3:45.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Patrick Ryan can be reached on 571-272-1292. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

John S. Maples Primary Examiner Art Unit 1745

JSM/9-21-2004